

SHEET 1 OF 1

FORM PTO-1449  
(Rev. 7-80)U.S. Department of Commerce  
Patent and Trademark OfficeATTY. DOCKET NO.  
000265SERIAL NO.  
09/583,386

## LIST OF PRIOR ART CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT  
L. Richard CarleyFILING DATE  
05/30/00GROUP  
2813

TECHNOLOGY CENTER 2800

SEP 20 2002

RECEIVED  
IF  
APPROPRIATE

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	IF APPROPRIATE	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
EL	AL	EP 0 624 900 A2	04/18/94	European			X	
	AM							
	AO							
	AP							

## OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EL	AR		Gianchandani, Y.B., Kim, H., Shinn, M., Ha, B., Lee, B., Najafi, K. and Song, C., "A MEMS-First Fabrication Process for Integrating CMOS Circuits with Polysilicon Microstructures", 1998 IEEE, pgs. 257-262
EL	AS		Kniffin, Margaret L., Shah, Mahesh, "Packaging for Silicon Micromachined Accelerometers", The International Society for Hybrid Microelectronics, Volume 19, Number 1, First Quarter 1996, pgs. 75-86
	AT		

EXAMINER

Eric Kishin

DATE CONSIDERED

9/27/02

\* EXAMINER Initial if reference considered, whether or not citation is in conformance with PEP 609. Draw line through question if not in conformance and not considered. Include copy of this form with next communication to applicant.